

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki et al. Art Unit : 2811
 Serial No. : 09/814,255 Examiner : Ori Nadav
 Filed : March 21, 2001 Conf. No. : 5578
 Title : SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

MAIL STOP AMENDMENT

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

Desig. ID	Source
AL	Japan 04273162 – English Abstract: esp@cenet.com .
AM	Japan 02215131 – English Abstract: esp@cenet.com
AN	Japan 04072744 – English Abstract: esp@cenet.com
AO	Japan 01152648 – English Abstract: esp@cenet.com
AP	Japan 04196420 – English Abstract: esp@cenet.com
AQ	Japan 04348548 – English Abstract: esp@cenet.com

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. I, the undersigned, hereby certify that each item of information contained in this statement was cited in a communication from a foreign patent office in a counterpart foreign application, JP Application 08-354803, the communication being dated June 12, 2007, which is not more than three months prior to the filing of this statement.

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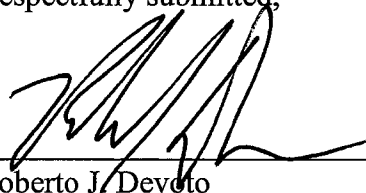
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Attorney's Docket No.: 07977-
107002 / US3194/3205/3215D1

Respectfully submitted,

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